



Patent
42534-3100

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yoichi Kato

Application No.: 09/591,565

Filed: June 9, 2000

For: NEGATIVE ION EMITTING
METHOD AND APPARATUS
THEREFOR

Patent Examiner: David A. Vanore

Group Art Unit: 2881

March 4, 2004

Irvine, California 92614-7230

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MAR 10 2004

PRELIMINARY AMENDMENT

Mail Stop RCE
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to an examination on the Request for Continued Examination, Applicant requests
that the following be considered.

03/09/2004 MGBREM1 00000020 192814 09591565

01 FC:2201 43.00 DA
02 FC:2202 63.00 DA